

High flux nano-XRD beamline for Science under extreme conditions

Beamline Team:

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Project Contributors:

Beamline conceptual design: K. Martel

Ray tracing simulations: J. Reyes Herrera and M. Sanchez del Rio

Heat load calculations: P. Brumund

Mirrors geometry and coatings: R. Barrett and C. Morawe

X-ray source definition: J. Chavanne

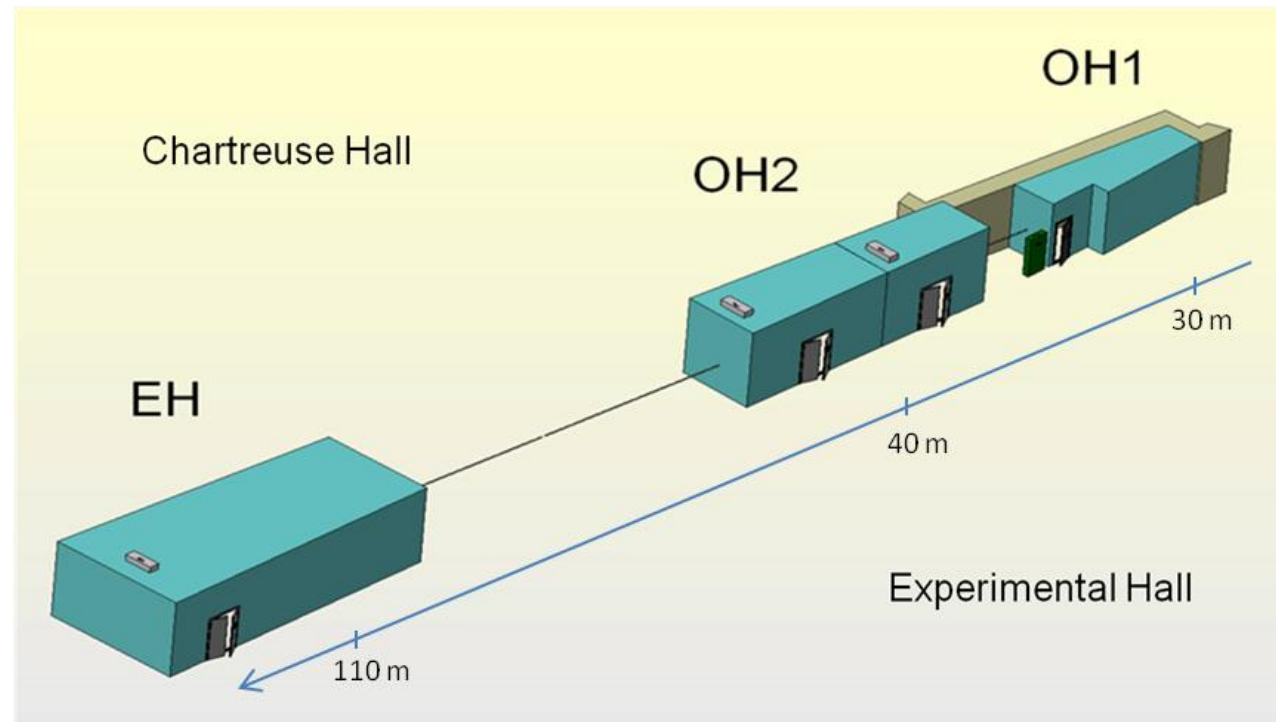
+Experts at the ESRF: P. Cloetens, R. Tucoulou, M. Di Michiel, V. Honkimaki, P. Boesecke, Y. Dabin, L. Eybert

and from external companies: Microplan, Cinel

GENERAL BEAMLINE CONFIGURATION

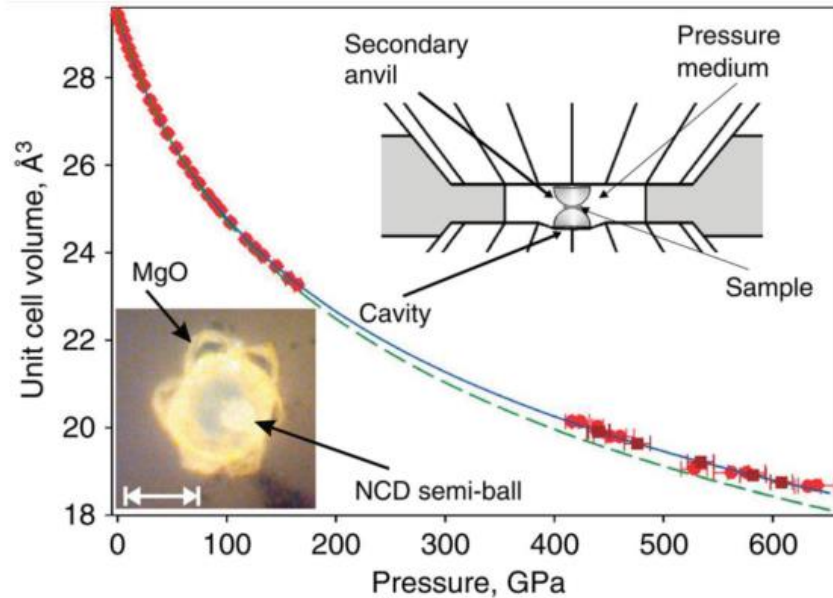
Main objectives:

- Build a new high pressure X-ray diffraction, fluorescence and imaging beamline.
- Take full advantage of the EBS to address the challenges defined in the scientific case.



Materials at and beyond the current limits of static pressures and high temperatures

Double-stage diamond anvil cell

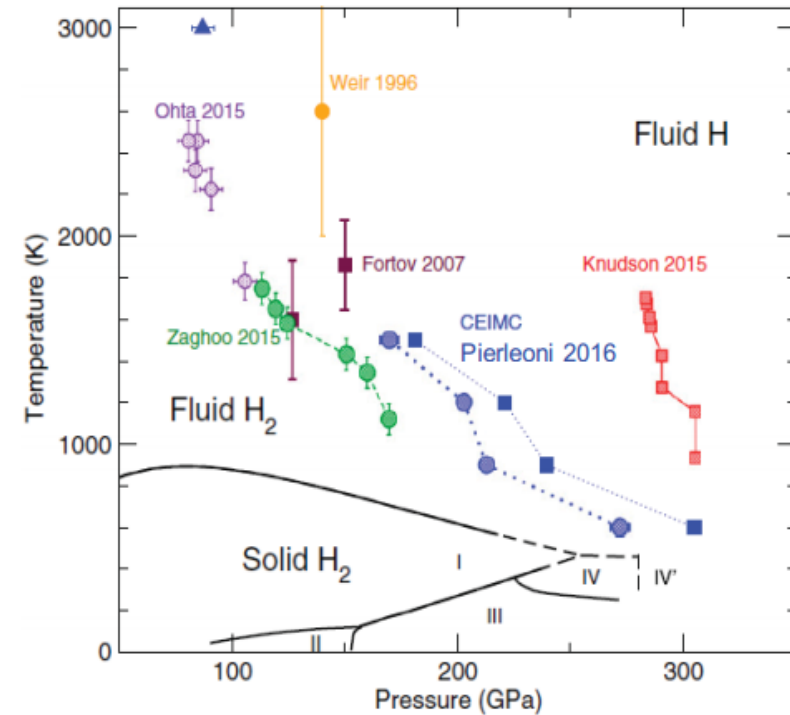


Pressure to 1000 GPa (10^7 bars)

Dubrovinsky et al., Nat. Comm., 2013

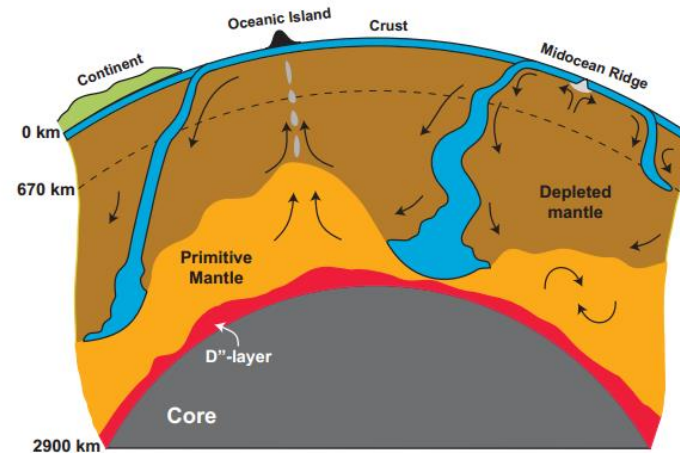
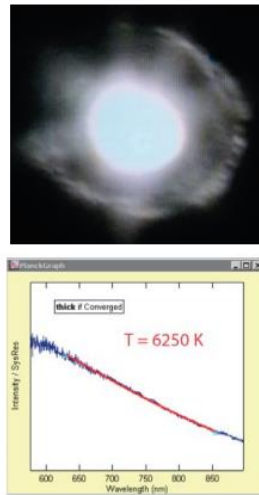
micro → nano-XRD

Solving the fluid H₂ to fluid H transition



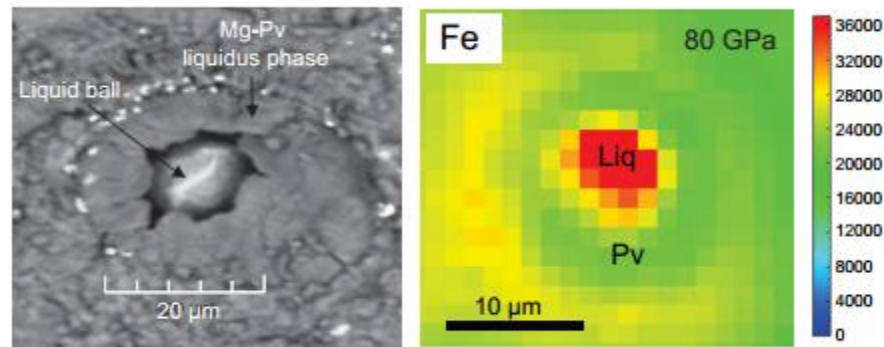
High photon flux
Monochromatic → Pink beam

Fast melting, kinetics of chemical reactions at extreme conditions



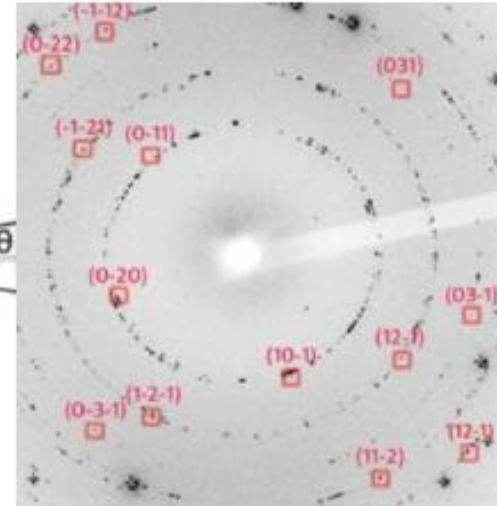
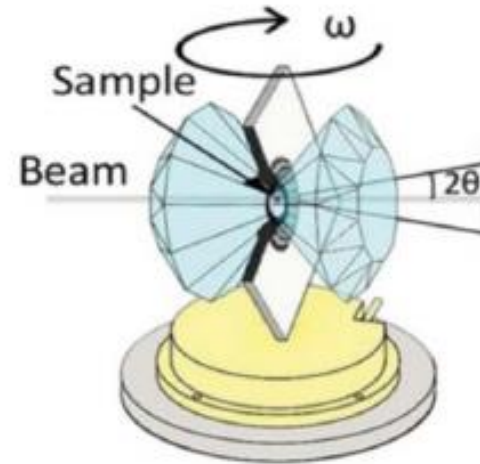
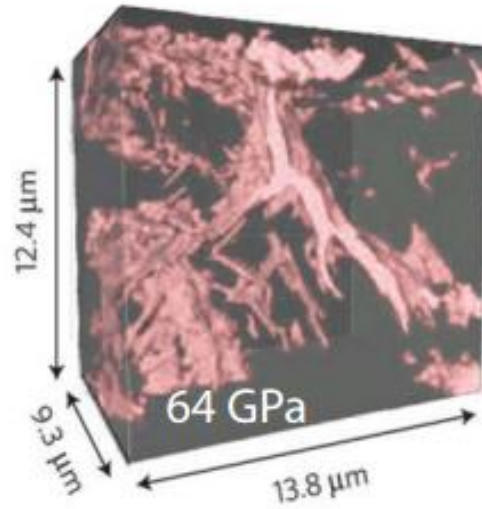
Derived from Kellog et al. 1999

Exploring extreme temperature states using laser heating

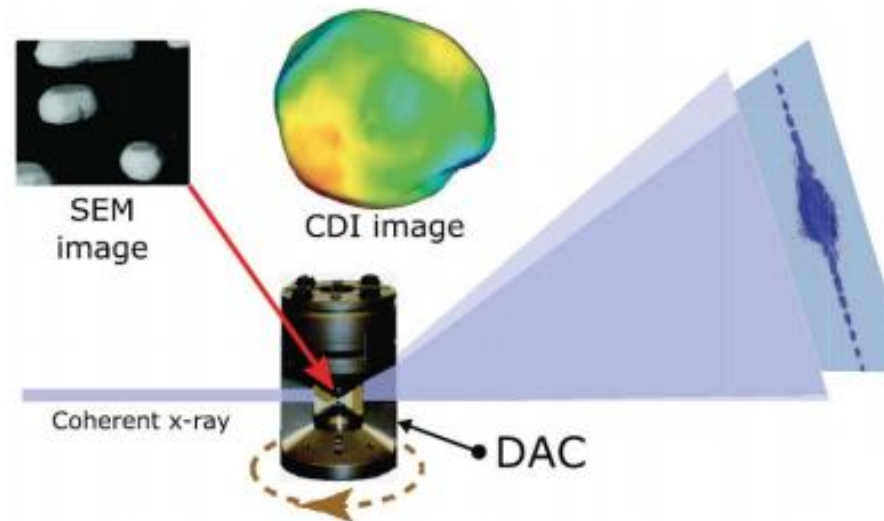


Converting ID27 into a nano-XRD/XRF beamline

New type of experiments: Tomography



Exploiting
X-ray beam
Coherence



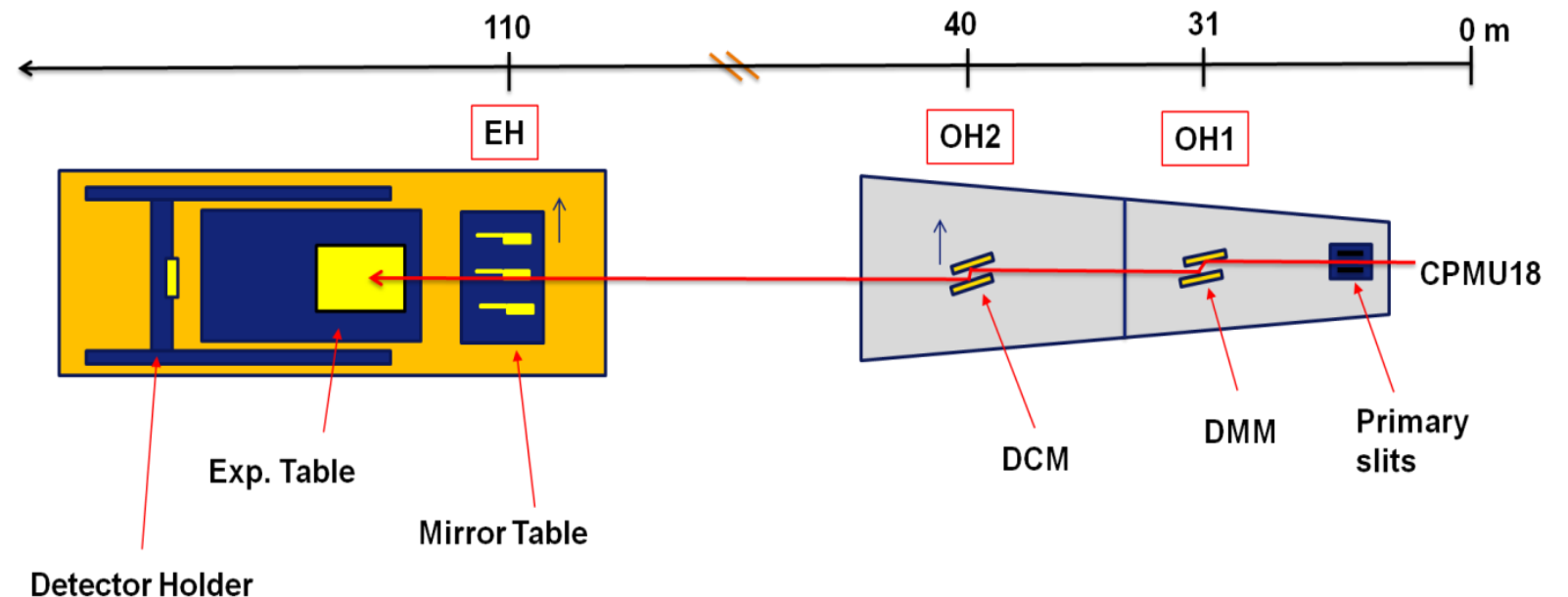
Providing XRI capabilities

basic principles:

- Reduce the number of optical elements to a minimum to improve the stability of the beamline and optimally exploit the intrinsic beam properties.
- Exploit the very low horizontal emittance of the EBS (No need for a secondary source)
→Simplified optical configuration in “horizontal geometry”

Main elements:

- Water-cooled DMM
- LN2-cooled Si(111) DCM
- Three KB mirrors

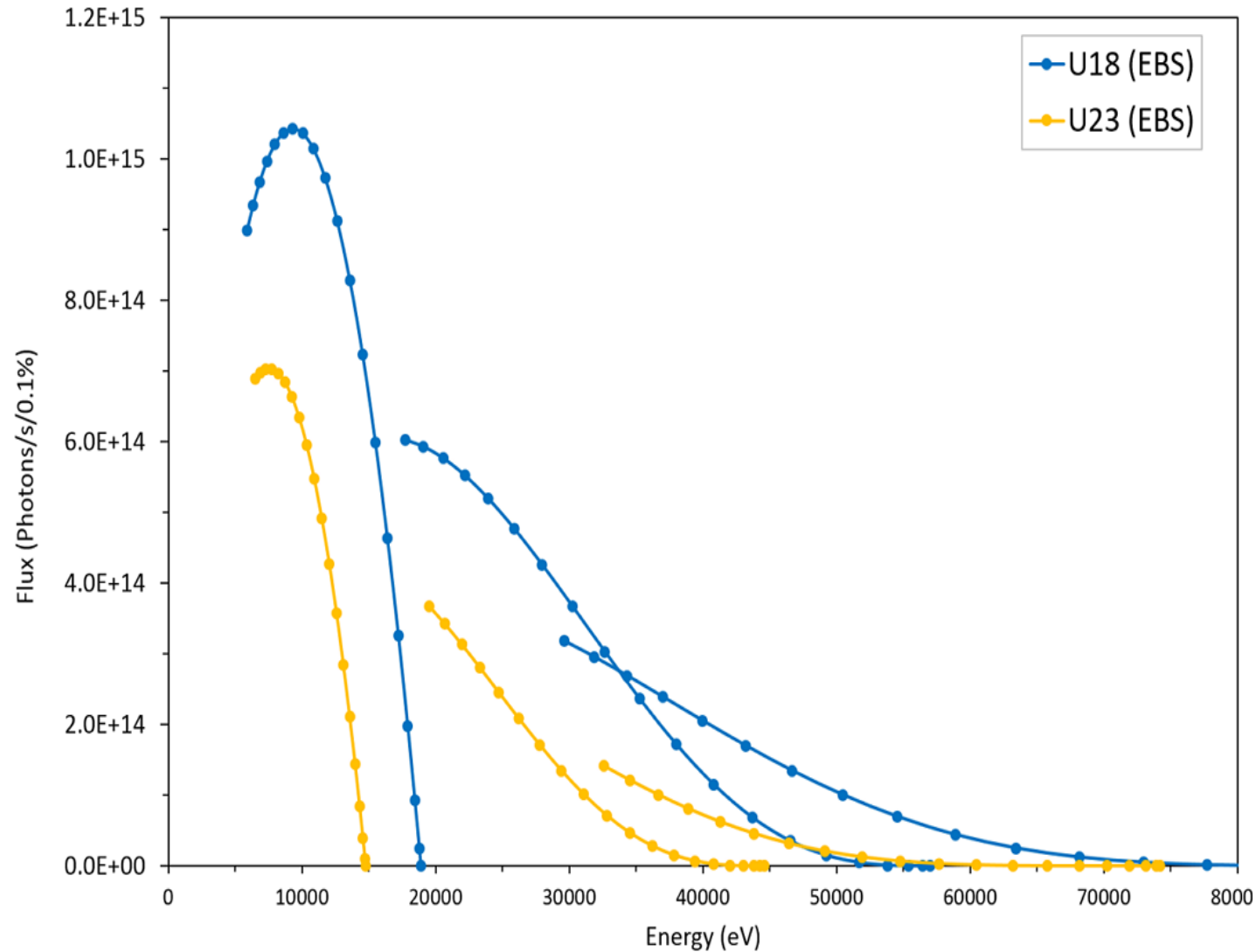


X-RAY SOURCE

-U18 cryo-undulator (CPMU18) placed in the middle of the ID27 straight section → minimum gap of 5mm (Kvalue=2.127).

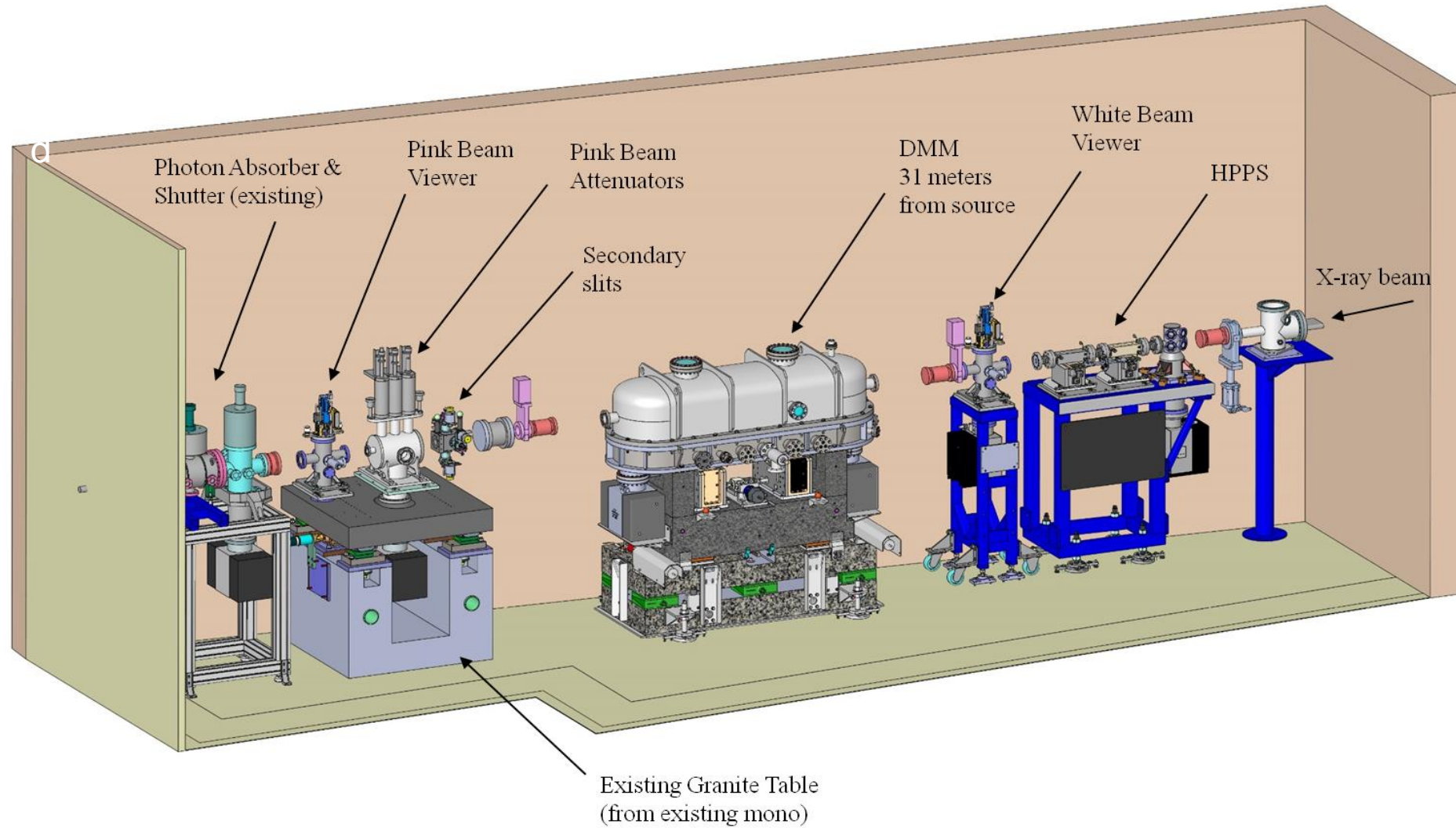
-Best system in terms of photon flux and tunability.

-It will replace the two currently installed U23 in-vacuum undulators.



OPTICAL DESIGN – OH1 WHITE BEAM OPTICAL HUTCH

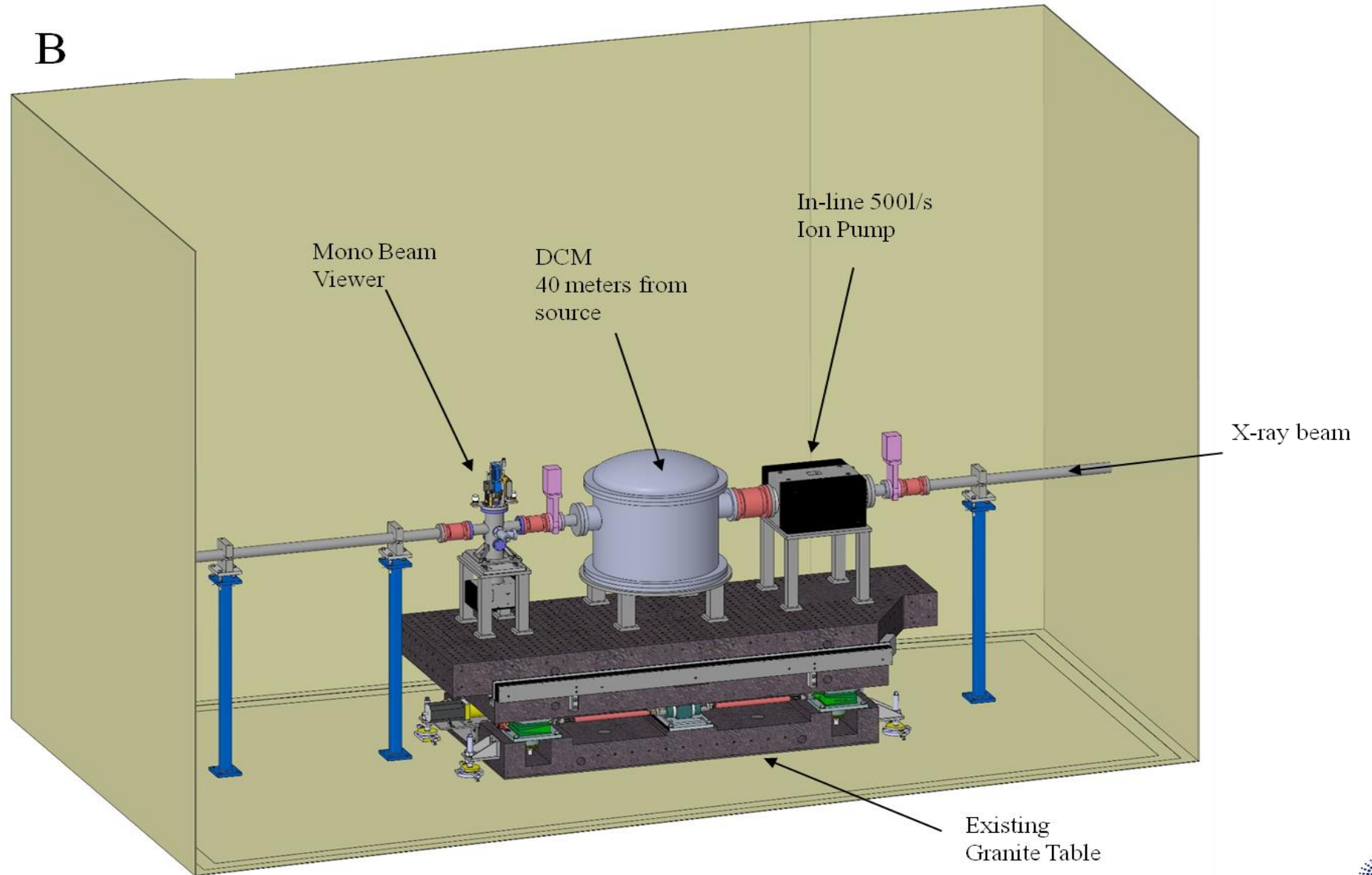
Re-used ID27/OH



OPTICAL DESIGN – OH2 “PINK” BEAM OPTICAL HUTCH

B

Re-used ID27/EH1



Large thermo-stabilized experimental hutch (± 0.1 K)

3 KB mirror systems for different beamspot sizes and energy domains

3 goniometers:

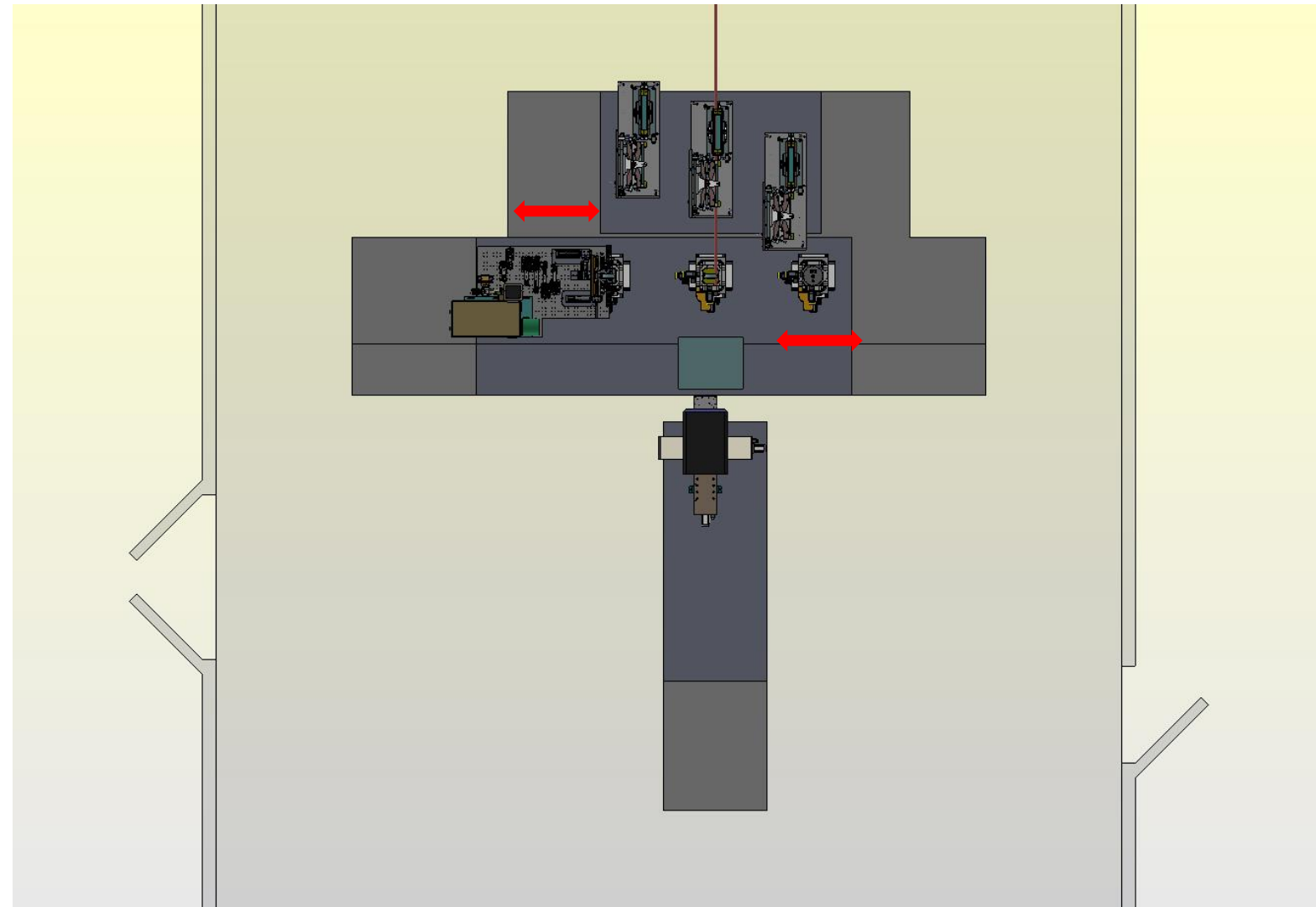
- Laser heating (YAG and CO₂)
- Heavy duty (PE press, cryostat)
- Nano-goniometer

3 detectors

Eiger2/CdTe for XRD

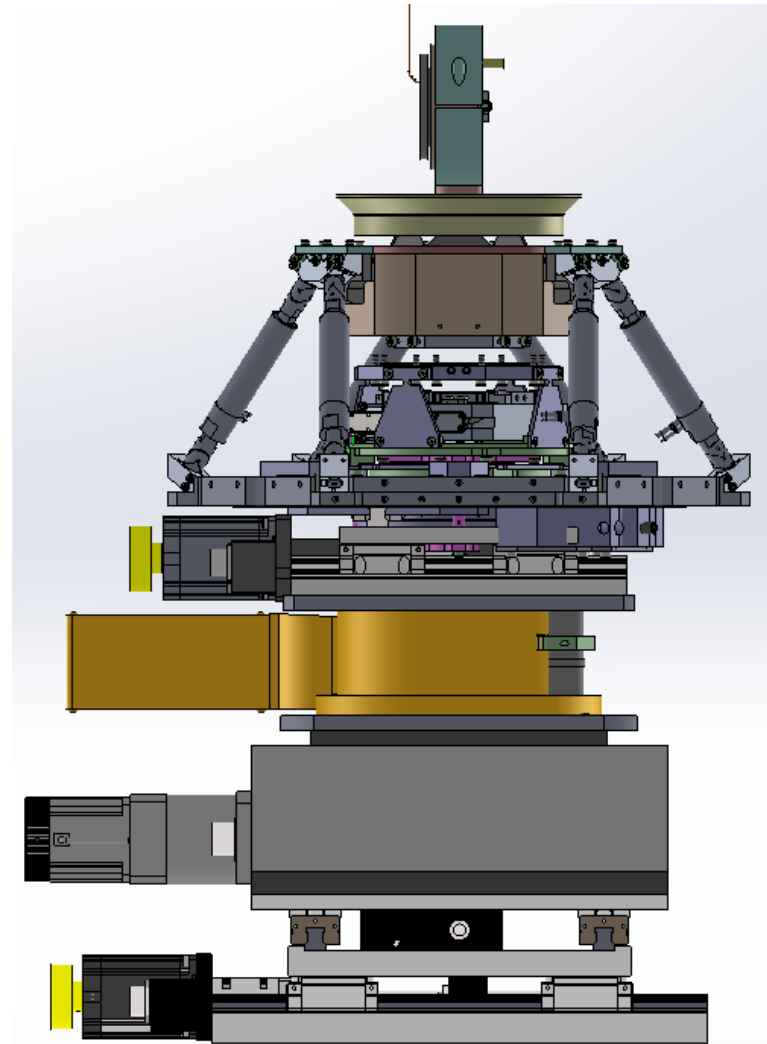
PCO/CMOS for XRI

Vortex SSD for XES



hexapod with 6 piezo-actuators

YZ scanning with 20 nm precision



	KB#1	KB#2	KB#3
Coating/Multilayer	Pt	W/B ₄ C	Ir/Al ₂ O ₃
Energy range (keV)	15-25	33(fixed)	30-60
Total Transmission	60-70%	74%	64% (at 30 keV)
$\Delta E/E$ FWHM	>10%	2%	2%
Length L_h/L_v (mm)	200/200	170/170	300/300
Useful M_h/M_v (mm)	180/180	140/140	250/250
$p_h(m)/q_h(m)$	110/0.30	110/0.50	110/1.2
$p_v(m)/q_v(m)$	110/0.55	110/0.70	110/0.80
Working distance from enclosure (mm)	200	450	550
Incidence angles at centre Maximum	$\theta_H=2.48$ mrad $\theta_v=2.71$ mrad $\theta_{max}=3$ mrad	$\theta_{cen}=7$ mrad	$\theta=7$ mrad at 30 keV
Aperture H/V (mm)	0.47/0.5	1.0/1.0	1.8/1.8
Slope errors (nrad)	100	100	300
ideal spot HxV (nm)	210/190	380/340	1700x2000
Target spot size VxH (nm)	200x300	350x500	2000x2000
Metrology	Fixed	Fixed	Bending

EXPECTED FLUX AT SAMPLE POSITION

Energy [keV]	15 (KB1)	33 (KB2)	60 (KB3)	ID27 old storage ring
Beam spot size HxV (μm)	0.22x0.28	0.47x034	2x2	2x3
Photons/s $\Delta E/E=1.5 \cdot 10^{-4}$ DCM	$7 \cdot 10^{12}$	$1.1 \cdot 10^{13}$	$2.2 \cdot 10^{12}$	$0.9 \cdot 10^{11}$ (at 33 keV)
Photons/s $\Delta E/E=2\%$ Pink beam	$5.0 \cdot 10^{14}$	$7 \cdot 10^{14}$	$1 \cdot 10^{14}$	NA

Gain x100 in monochromatic to x1000 in pink beam



Frame rate: 0.2 Hz
Sensitivity <20 % at 30 keV
dynamic range: 13 bits

Frame rate: 250 Hz
Sensitivity >90 % at 30 keV
dynamic range: 20 bits

Timetable of the project:

- Nov. 2019: Technical Design Report
- Feb. 2020: Beginning of construction
- March 2021: Radiation test
- April: Beamline commissioning
- Mai-June 2021: User operation